

PATENT
Attorney Docket No.: SSI-00501

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:) Group Art Unit: 1763
Maximilian A. Biberger et al.) Examiner: Ram N. Kackar
Serial No.: 09/912,844) AMENDMENT AND RESPONSE
Filed: July 24, 2001)
For: HIGH PRESSURE PROCESSING CHAMBER FOR SEMICONDUCTOR SUBSTRATE) 162 North Wolfe Road Sunnyvale, California 94086 (408) 530-9700
) Customer No.: 28960

Mail Stop Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:
Please amend the above-titled application as follows:

CERTIFICATE OF FACSIMILE TRANSMISSION	
I hereby certify that this paper (along with any referred to as being attached or enclosed) is being facsimile transmitted to the Patent and Trademark Office at:	
703 746-8364	
on the date shown below.	
Date: 8/6/03	By: [Signature] HAYESSTOCK & COVENT LLP